

Image



Attorney's Docket No.: 10417-101001 / F51-136645M/SW

2822

Applicant : Haruo Hyodo et al.
Serial No. : 09/963,267
Filed : September 26, 2001
Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

Art Unit : 2822
Examiner : Ida M. Soward

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicant submits the references listed on the attached form PTO-1449. A copy of a communication from the European Patent Office (EPO) in a counterpart application is also enclosed.

Submitted herewith are English-language abstracts for listed references AJ and AK.

This statement is being filed after a first Office action on the merits, but before receipt of a final Office action or a Notice of Allowance. I, the undersigned, hereby certify that each item of information contained in this statement was cited in the enclosed communication from the EPO in a counterpart foreign application, the communication being dated February 17, 2004, which is not more than three months prior to the filing of this statement.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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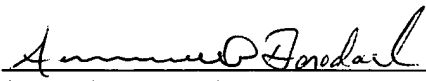
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Respectfully submitted,

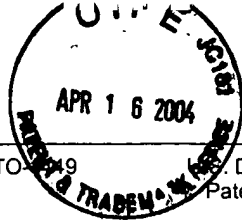
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Substitute Form PTO-1449 (Modified) Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 10417-101001	Application No. 09/963,267
	Applicant Haruo Hyodo et al.		
	Filing Date September 26, 2001	Group Art Unit 2822	

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	5,923,958	07/13/1999	Chou			
	AB	5,160,787	11/03/1992	Gaku et al.			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	English Abstract	
							Yes	No
	AI	EP 0 997 934	05/03/2000	Europe				
	AJ	DE 19959938A1	10/05/2000	Germany			X	
	AK	DE 19752196C1	02/11/1999	Germany			X	
	AL							
	AM							

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AN	
	AO	
	AP	
	AQ	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	